



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of: Renerus Antonius
Van Den Heuvel

Art Unit: 2823

Serial No.: 10/014,243

Dkt. #: NL000674

Filed: 12/11/2001

Examiner: Maldonado, Julio J.

Title: METHOD FOR THE MANUFACTURE
OF A SEMICONDUCTOR DEVICE WITH
A FIELD-EFFECT TRANSISTOR

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Commissioner for Patents
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AFTER-FINAL AMENDMENT

Sir:

I. INTRODUCTORY COMMENTS:

In response to the Final Office Action of October 3, 2003, please amend the above-referenced patent application as follows: